

843.37558VX2



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): FUNABASHI

Serial No.: 09/902,672

Filed: July 12, 2001

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE

Group: 2825

Examiner: L. Malsawma

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AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

May 6, 2002

Sir:

In response to the Office Action mailed December 5, 2001, please amend
the above-identified application as follows:

IN THE CLAIMS

Please cancel claims 1-16, all of the claims previously considered on the
merits in the above-identified application, and substitute therefor the following
new claims: